INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 16, 2026

IGI Report Number	LG837677916
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MODIFIED OCTAGON STEP CUT
Measurements	7.36 X 7.18 X 4.47 MM

GRADING RESULTS

Carat Weight	2.22 CARATS
Color Grade	E
Clarity Grade	VVS 2

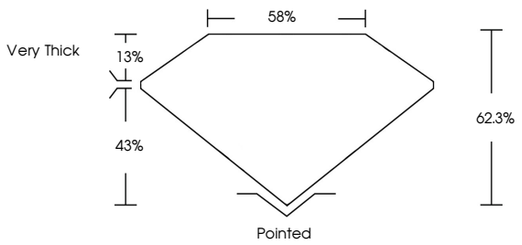
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG837677916

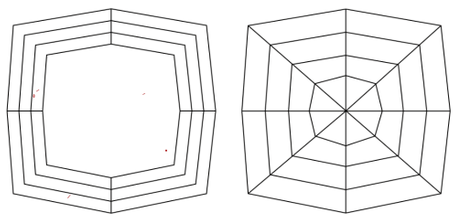
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG837677916
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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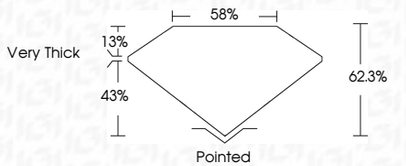

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IGI

September 16, 2026
IGI Report No LG837677916
MODIFIED OCTAGON STEP CUT
7.36 X 7.18 X 4.47 MM
2.22 CARATS
E
VVS 2
62.3%
58%
Very Thick
Pointed
EXCELLENT
EXCELLENT
NONE
LG837677916
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa